

Our ref: KON-2020

Client's ref: P6636-001-0000 (US)

JC20 Rec'd PCT/PTO 28 JUL 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of :
Hiromoto, II, et al

International Application No. :
PCT/JP2004/010085

International Filing Date: 8 July 2004: Dated: July 28,
2005

Title : FILM FORMING METHOD AND :
SUBSTRATE HAVING A FILM
FORMED BY THE METHOD :
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PRELIMINARY AMENDMENT

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

S i r:

Attached are Specification Amendments, Claim
Amendments, and Remarks, each starting on a separate page.